



WN-1439

1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

K. Kata et al.

Serial No.: 08/533,207

Group Art Unit: 2503

Filed: September 25, 1995

Examiner: M. Prenty

For: PROCESS FOR MANUFACTURING SEMICONDUCTOR DEVICE
AND SEMICONDUCTOR WAFERAssistant Commissioner of Patents and Trademarks
Washington, D.C. 20231AMENDMENT UNDER 37 C.F.R. §1.111 AND
RESPONSE TO RESTRICTION REQUIREMENTRECEIVED
FEB 6 3 1997
GROUP 2500

Sir:

In response to the Office Action mailed January 3, 1997, please amend
the above-identified application as follows and please consider the following:

IN THE SPECIFICATION:

Page 4, line 28, delete "one of".

Page 5, line 22, delete "a";

line 25, delete "With" and insert --In--.

Page 11, line 8, delete "ten" and insert --tens of--;

line 22, delete "21" and insert --11--.

(NE) Page 12, line 28, delete "the" and insert --a--.

Page 13, line 10, after "to" insert --an--.

Page 14, line 17, delete "a";

lines 22-23, delete "troubles and".

Page 15, line 9, delete "of" and insert --or--;

line 10, before "adequate" insert --a plurality of--;

line 28, delete "inward" and insert --inwardly of--.

Page 16, line 13, delete "on";

Election
7/A
2-5-97
T.F.